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Patent

Atty. Docket: H60-099 US

CERTIFICATE OF MAILING

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT

Han's Martin Buschbeck, et al

SERIAL NO.

09/975,885

FILED

October 12, 2001

EXAMINER

N/A

GROUP ART UNIT

N/A

FOR

METHOD FOR PRODUCING COMPONENTS

AND ULTRAHIGH VACUUM CVD REACTOR

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.98

Sir:

In accordance with the provisions of 37 C.F.R. §1.98, applicants submit, on the accompanying Form PTO-1449, a listing of documents which the Patent Office is asked to consider. A copy of each listed document is submitted herewith with an explanation of the relevance for any non-English listed item. A copy of the European Search Report is also enclosed.

The submission of any document and information herewith, which is not a statutory bar, is not intended as an admission that such constitutes prior art against the claims of the present application.

Applicants do not waive any right to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document or information which is determined to be a <u>prima facie</u> prior art reference or information against the claims of the present application.

Applicants respectfully request that the foregoing information and listed documents be considered by the Examiner, and formally be made of record in the present application, and that an initialized copy of said Form PTO-1449 be returned in accordance with M.P.E.P. § 609.

Entry of the Information Disclosure Statement is respectfully requested.

Respectfully submitted,

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Attachments